

FIG. 3

METHOD OF FABRICATING MICROMACH. D DEVICES

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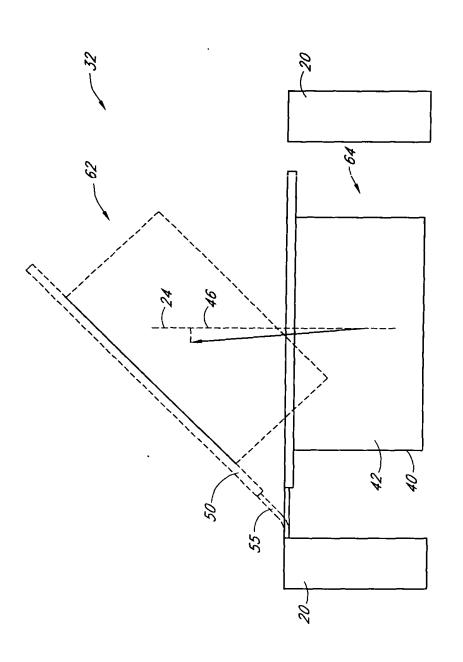
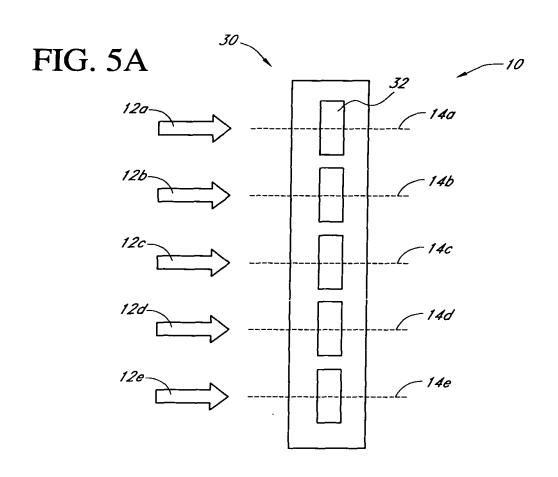
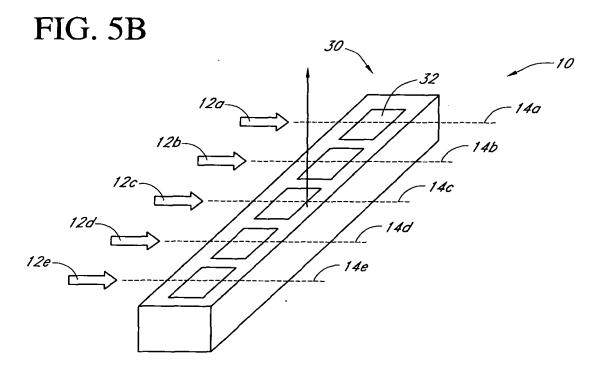


FIG. 4

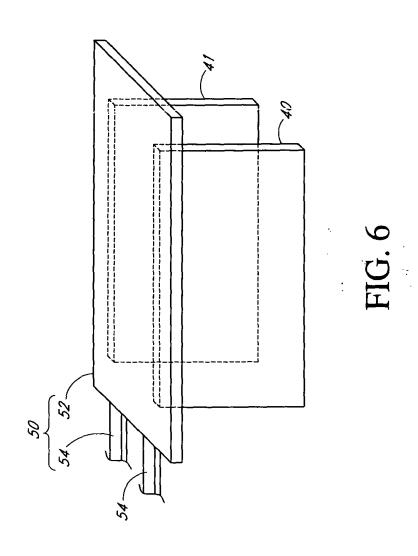




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FIG. 7A

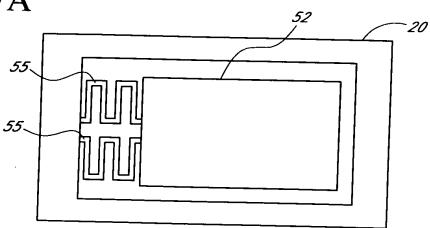


FIG. 7B

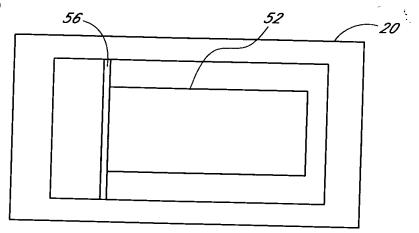
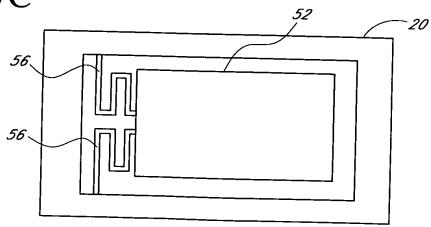


FIG. 7C



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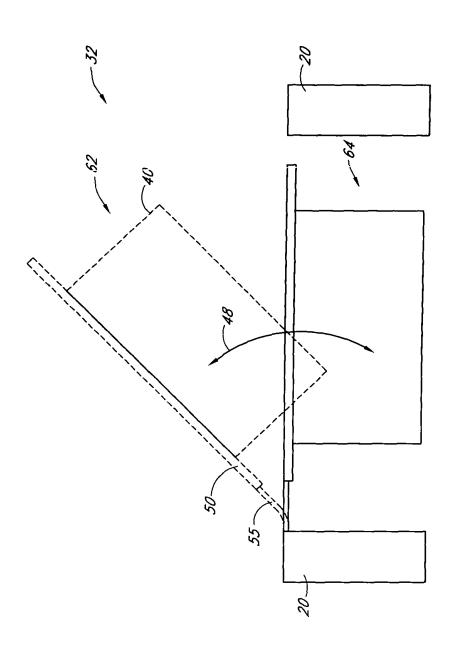


FIG. 8

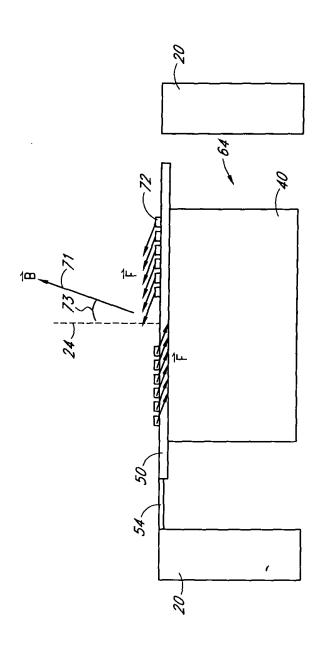


FIG. 9

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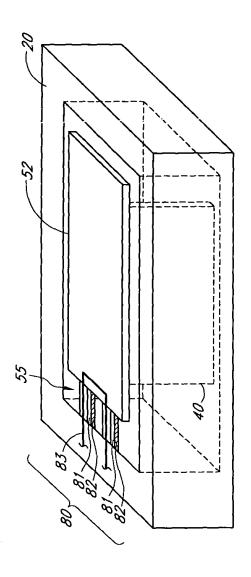
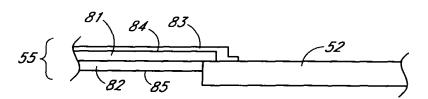


FIG. 10

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FIG. 11A

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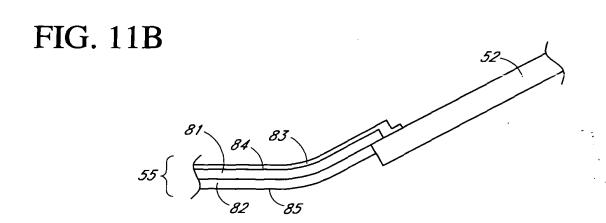
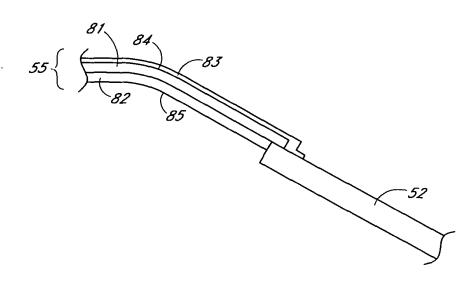
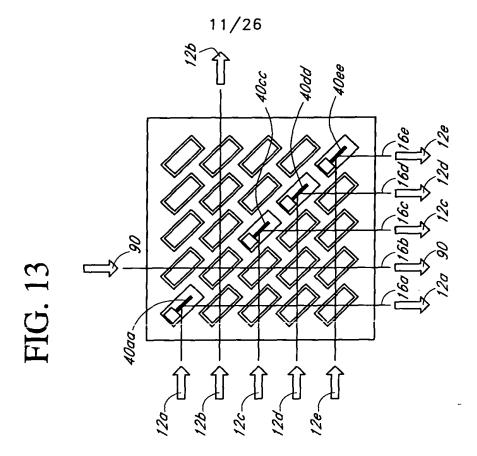


FIG. 11C





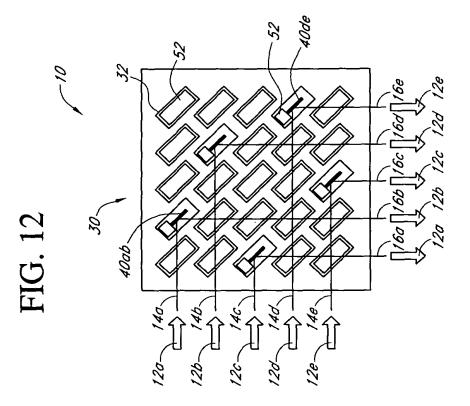


FIG. 14

FIG. 15A

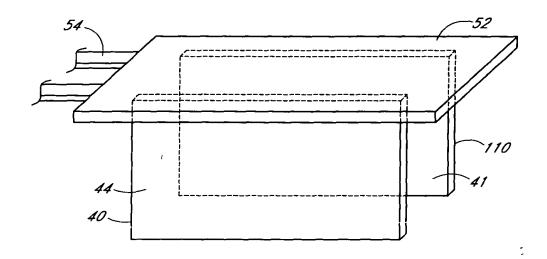
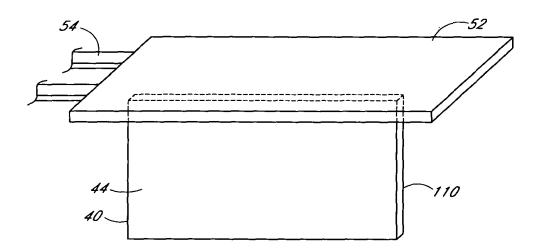
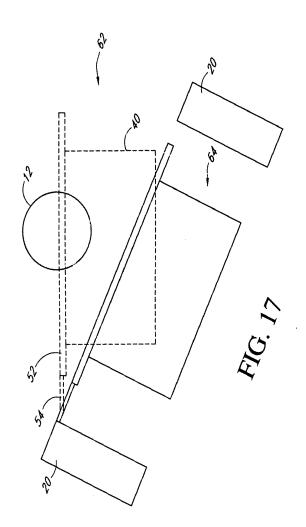


FIG. 15B



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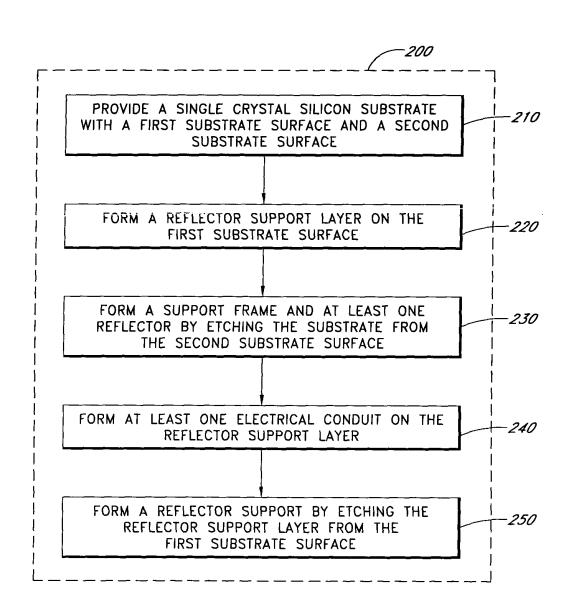


FIG. 18

FIG. 19A

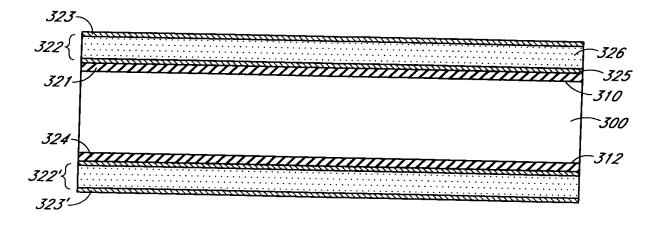


FIG. 19B

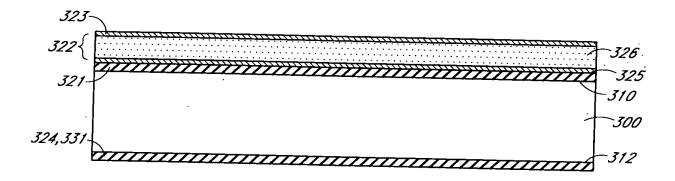


FIG. 19C

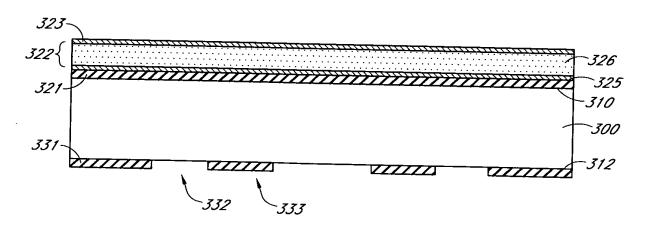


FIG. 19D

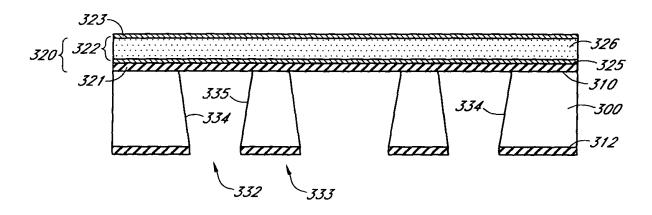


FIG. 19E

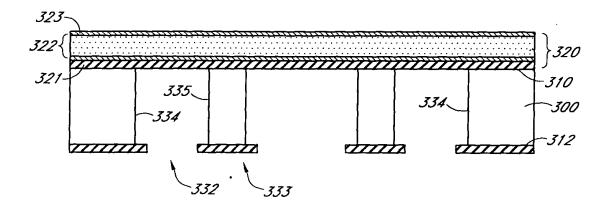


FIG. 19F

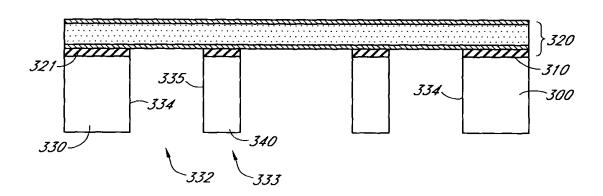


FIG. 19G

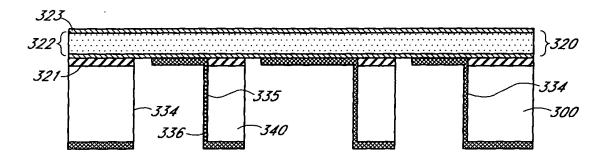


FIG. 19H

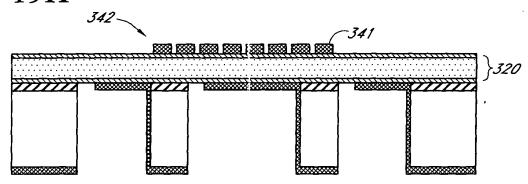
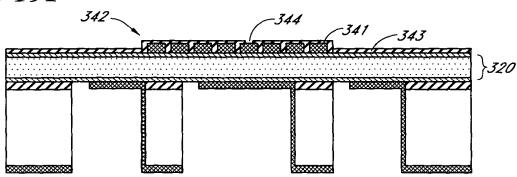


FIG. 19I



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FIG. 19J

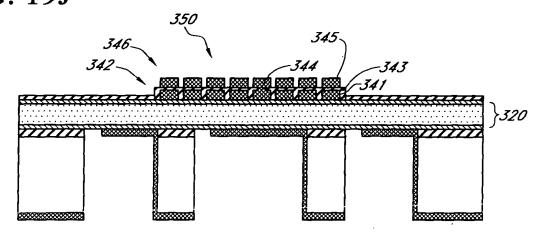
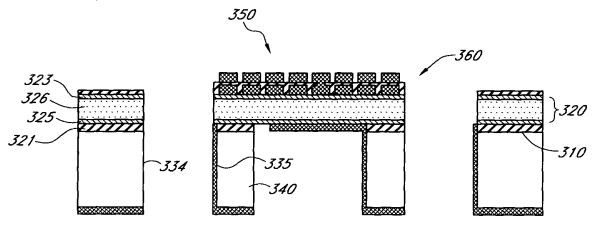


FIG. 19K



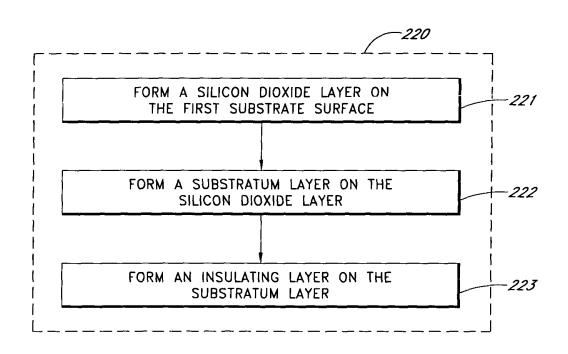


FIG. 20

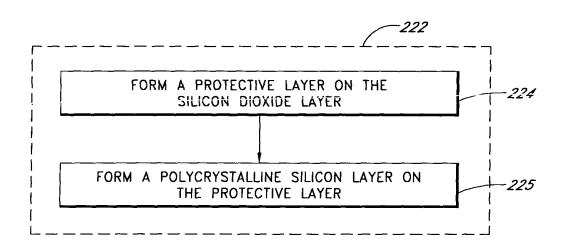


FIG. 21

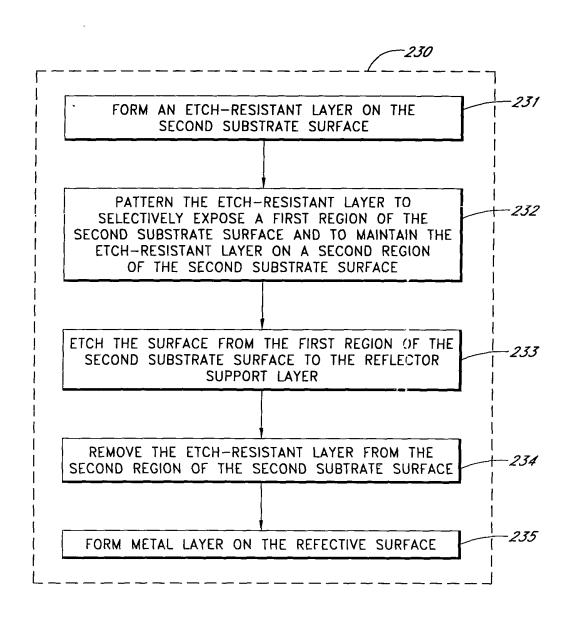


FIG. 22

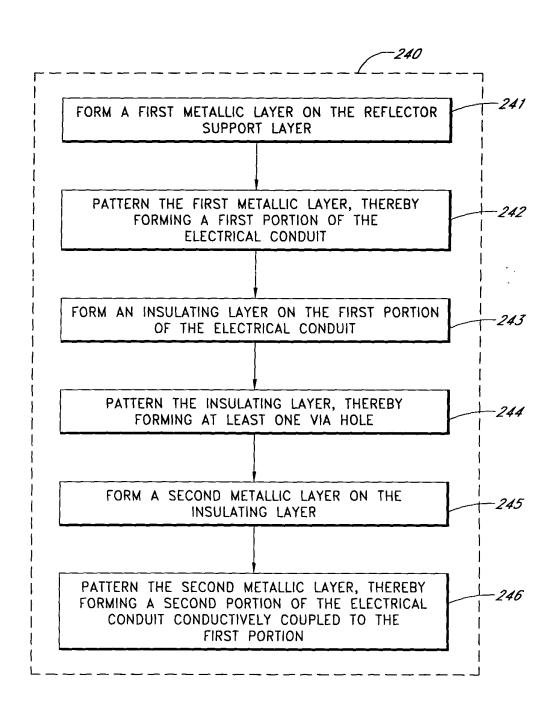


FIG. 23

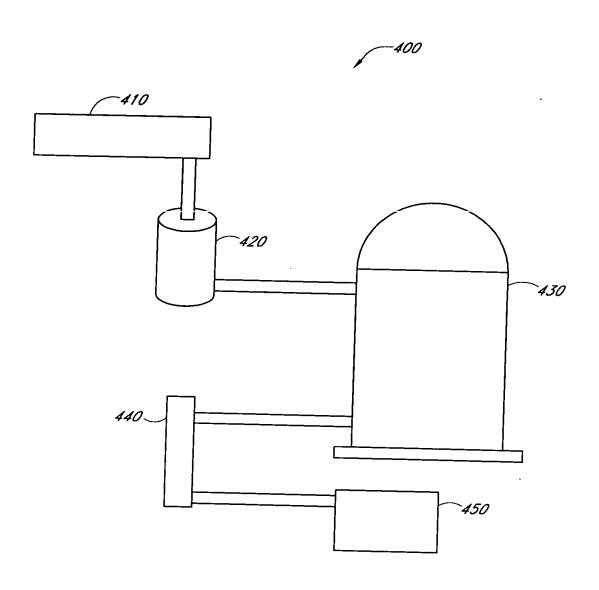


FIG. 24

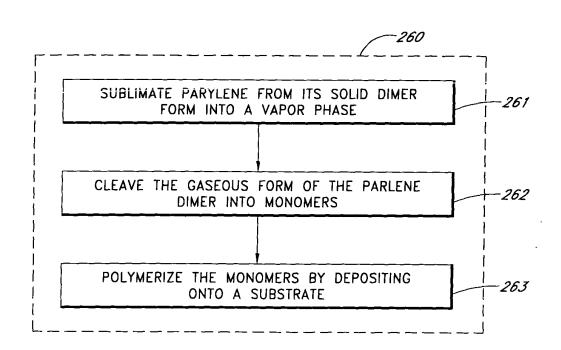


FIG. 25

FIG. 26A

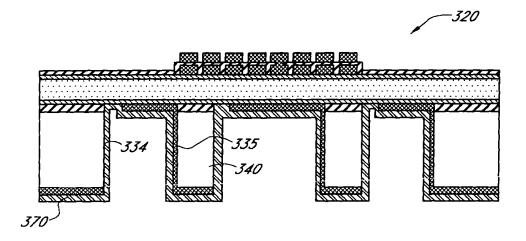


FIG. 26B

